	Application No.	Applicant(s)
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Notice of Allowability	10/676,876 Examiner	VERNON ET AL.  Art Unit
·		
	Brian M. Healy	2883
The MAILING DATE of this communication appr All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in thing or other appropriate communice IGHTS. This application is subjection in the communication in the communication is subjection.	s application. If not included ation will be mailed in due course. THIS
1. $\boxtimes$ This communication is responsive to <u>the application filed (</u>	09/30/2003.	•
2. X The allowed claim(s) is/are <u>1-33</u> .		
3. X The drawings filed on 30 September 2003 are accepted by	y the Examiner.	
<ul> <li>4. ☐ Acknowledgment is made of a claim for foreign priority una) ☐ All b) ☐ Some* c) ☐ None of the:</li> <li>1. ☐ Certified copies of the priority documents have</li> <li>2. ☐ Certified copies of the priority documents have</li> <li>3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	e been received. e been received in Application N	o
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a re MENT of this application.	eply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv	nitted. Note the attached EXAMII es reason(s) why the oath or de	NER'S AMENDMENT or NOTICE OF claration is deficient.
6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") must (a) ☐ including changes required by the Notice of Draftspers 1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner' Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the second sheet.	son's Patent Drawing Review(F .· s Amendment / Comment or in t l.84(c)) should be written on the d	the Office action of rawings in the front (not the back) of
DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERI	AL must be submitted. Note the
<ul> <li>Attachment(s)</li> <li>1.  Notice of References Cited (PTO-892)</li> <li>2.  Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3.  Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date 03162005</li> <li>4.  Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. ☐ Interview Sumn Paper No./Mai 7. ☐ Examiner's Am 8. ☑ Examiner's Sta 9. ☐ Other	l Date .

Application/Control Number: 1

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Art Unit: 2883

## **DETAILED ACTION**

## Allowable Subject Matter

The following is an examiner's statement of reasons for allowance: The closest prior art of record, Kuo, U.S.P. No. 5,946,562, teaches (Figs.1-9) a method and apparatus for forming thin film transistors in an amorphous silicon layer 110,100 using a beam 119 to selective anneal portions of the amorphous silicon layer. Neither Kuo 562' or any of the other cited references of record teaches or suggests the claimed direct patterning method and apparatus of fabricating an optical waveguide comprising: depositing an amorphous silicon film on a substrate; and crystallizing selected regions of the amorphous silicon film to bound at least one non-selected region of the amorphous silicon film between the crystallized selected regions in alternating arrangements wherein the crystallized selected regions in alternating arrangement, wherein the crystallization reduces the refractive index of the selected regions below the refractive index of the at least one non-selected region. The crystallization is performed using a laser recrystallization technique. In addition, neither Kuo 562' or any of the other references of record teaches or suggests an optical waveguide comprising: a monolithic structure having at least one as-deposited amorphous silicon (a-Si) core region, and at least one pair of annealed polysilicon silicon (p-Si) cladding regions bounding the a-Si core region(s) on opposite sides thereof in alternating arrangement with the annealed p-Si cladding regions having a lower index of refraction than the a-Si core region(s). The independent claims 1,11,21 and 28 contain the aforementioned limitations and the remaining dependent claims 2-10,12-20,22-27 and 29-33 contain the

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limitations of the independent claims as well as other additional limitations (See the dependent claims for these specific limitations. The additional art cited on PTO-892 is for backround purposes only. A copy of PTO-1449 will be included in this office action.

Any comments considerednecessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Brian M. Healy whose telephone number is (571)272-2347. The examiner can normally be reached on Compressed schedule Tues –Thurs. 7AM-4:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Frank Font can be reached on (571)272-2415. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

## Brian M. Healy

Primary Examiner Art Unit 2883

Brian Healy Primary Examiner